

Application Data Sheet**Application Information**

Application Type::	Regular
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD FOR FABRICATING A SIGE FILM, SUBSTRATE FOR EPITAXIAL GROWTH AND MULTILAYERED STRUCTURE
Attorney Docket Number::	117787
Total Drawing Sheets::	4
Small Entity::	Yes

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Akira
Family Name::	SAKAI
City of Residence::	Nagoya City
State or Province of Residence::	Aichi pref
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Osamu
Family Name::	NAKATSUKA
City of Residence::	Nagoya City
State or Province of Residence::	Aichi pref
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Shigeaki

Family Name:: ZAIMA
City of Residence:: Kasugai City
State or Province of Residence:: Aichi pref
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Yukio
Family Name:: YASUDA
City of Residence:: Aichi-Gun
State or Province of Residence:: Aichi pref
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-335165	11/19/2002	Yes
Assignee Information			
Assignee Name::		NAGOYA UNIVERSITY	
Street of mailing address::		FURO-CHO, CHIKUSA-KU	
City of mailing address::		NAGOYA CITY	
State or Province of mailing address::		AICHI PREF	
Country of mailing address::		JAPAN	